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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/753,406 Confirmation No. : 6394
First Named Inventor : Masayuki KOBAYASHI
Filed : January 9, 2004
TC/A.U. : 2812

Docket No. : 056203.53141US
Customer No. : 23911

Title : WORKING METHOD OF METAL MATERIAL AND
SEMICONDUCTOR APPARATUS FABRICATED BY THE METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS REQUEST

Sir:

Our records indicate that we have not received any further correspondence in reference to the above-identified application since August 4, 2004, when we received the Notice of Publication of Application. Please advise the undersigned of the status of the application.

It would be appreciated if the undersigned were telephoned in the event there are any questions related to this Request or the application in general.

Respectfully submitted,

January 12, 2005


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